

Title (en)

Process for the production of PTC thermistors.

Title (de)

Verfahren zum Herstellen von PTC-Thermistoren.

Title (fr)

Procédé de fabrication de thermistors PTC.

Publication

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Application

EP 84303796 A 19840605

Priority

JP 10448383 A 19830611

Abstract (en)

A process for the production of glass sealed types PTC thermistors is disclosed wherein a positive temperature coefficient semiconductor ceramic material (1) is sealed in a glass (4) having a softening point of no higher than 560 DEG C in the presence of air, oxygen or an air/oxygen mixture.

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